

Electronic Acknowledgement Receipt

EFS ID:	5040603
Application Number:	10690507
International Application Number:	
Confirmation Number:	6043
Title of Invention:	Method for manufacturing polycrystalline silicon thin film and thin film transistor fabricated using polycrystalline silicon thin film manufactured by the manufacturing
First Named Inventor/Applicant Name:	Ji Yong Park
Customer Number:	49455
Filer:	Randall Scott Svihla/Jennifer Oakley
Filer Authorized By:	Randall Scott Svihla
Attorney Docket Number:	0091.1032
Receipt Date:	26-MAR-2009
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Application Type:	Utility under 35 USC 111(a)

Payment information:

Submitted with Payment	yes
Payment Type	Credit Card
Payment was successfully received in RAM	\$540
RAM confirmation Number	114
Deposit Account	
Authorized User	

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
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1		NoticeOfAppeal- PreAppealBrief_03-26-09.pdf	878347 <small>5482c2ed8d1cacab419c772677c1d9416d cbe85</small>	yes	9
Multipart Description/PDF files in .zip description					
		Document Description	Start	End	
		Notice of Appeal Filed	1	2	
		Pre-Brief Conference request	3	9	
Warnings:					
Information:					
2	Fee Worksheet (PTO-06)	fee-info.pdf	29950 <small>d5c1c022c083aac09b1b2c0ba1174db7c 9021a</small>	no	2
Warnings:					
Information:					
Total Files Size (in bytes):			908297		
<p>This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.</p> <p><u>New Applications Under 35 U.S.C. 111</u> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p> <p><u>National Stage of an International Application under 35 U.S.C. 371</u> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p> <p><u>New International Application Filed with the USPTO as a Receiving Office</u> If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.</p>					